

<b>Notice of References Cited</b>	Application/Control No. 10/594,338		Applicant(s)/Patent Under Reexamination MIWA ET AL.	
	Examiner Lisa Chau		Art Unit 1794	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2002/0007875	01-2002	Yamamoto et al.	148/302
*	C	US-6,326,087	12-2001	Nishiuchi et al.	428/611
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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